



IFW

PATENT
81872.0052

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

INOMATA, et al.

Serial No: 10/650,504

Filed: August 27, 2003

For: DRY ETCHING APPARATUS, DRY
ETCHING METHOD, AND PLATE
AND TRAY USED THEREIN

Art Unit: 1763

Examiner: Not Assigned

STATUS REQUEST

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence
is being deposited with the United States
Postal Service with sufficient postage as
first class mail in an envelope addressed
to:

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450, on
October 29, 2004

Date of Deposit

Evelyn Menjivar

Name

Signature

10/29/04

Date

Dear Sir:

This application was filed on August 27, 2003 and receipt by the U.S. Patent and Trademark Office was acknowledged in the Filing Receipt dated January 9, 2004. A Notice of Publication of Application was the last correspondence from the Patent Office. However, no Office Action has yet been received. Accordingly, Applicants request to be advised of the status of the application, including an indication of when the patent application is expected to be examined.

Please send the undersigned a Status Report on this application.

Respectfully submitted,
HOGAN & HARTSON L.L.P.

Date: October 29, 2004

By:

Lawrence J. McClure

Registration No. 44,228

Attorney for Applicant(s)

500 South Grand Avenue Suite 1900
Los Angeles, California 90071
Telephone: 213 337-6700
Facsimile: 213 337-6701